

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Ismail Emesh et al.

Group Art Unit: 3723

Serial No.: 10/729,119

Examiner: Shakeri, Hadi

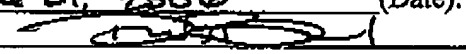
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For: LUBRICANT FOR WAFER POLISHING USING A FIXED ABRASIVE PAD

Attorney Docket No.: 004.0122

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RESPONSE AND AMENDMENT

FILED WITH REQUEST FOR CONTINUED EXAMINATION

MAIL STOP RCE
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is filed with a Request for Continued Examination, and is a complete response to the final Office Action mailed on April 19, 2006. Please amend the above-identified application as set forth below.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.